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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
<i>AM</i>	AA 5,731,079	Hammond et al.	03/24/98	—	—	
	AB					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
<i>AM</i>	AC 0 166 349 A1	01/02/86	EPO	Yes. See PCT search report.
<i>AM</i>	AD 0 685 439 A2	12/06/95	EPO	Yes. See PCT search report.

OTHER DOCUMENTS

<i>AM</i>	AE	Münz et al.; Journal of Vacuum Science & Technology, Vol.4, No. 6, pp. 2717-2752, Nov. 1986. See PCT search report.
<i>AM</i>	AF	Vaz et al.; Surface & Coating Technology, Elsevier, Vol. 108-109, pp. 236-240, Oct. 1998. See PCT search report.
<i>AM</i>	AG	Sun et al.; Journal of Applied Physics, U.S. American Institute of Physics, Vol. 81, No.2, pp.656-663, Jan. 1997. See PCT search report.
<i>AM</i>	AH	Takano et al.; Surface & Coatings Technology, Elsevier, Vol. 84, No.1-3, pp.409-413, Oct. 1996. See PCT search report.
<i>AM</i>	AI	Shew et al.; Thin Solid Films, Elsevier, Vol. 293, No. 1-2, pp. 212-219, 1997. See PCT search report.
<i>AM</i>	AJ	Patent Abstract of Japan, Publication No. 05250770, Sept. 28, 1993. See PCT search rpt.

Examiner

Turner

Date Considered

8/10/02